



YES-PB Series

(PB8 and PB12)

Manual Load Vacuum Cure Systems

The YES-PB Series is the result of decades of experience in the design and manufacture of low particle ovens. These dependable systems provide complete removal of residual solvents, uniform temperature distribution, pressure control, a dry inert atmosphere, and precise management of heating and cooling rates.

PB8: up to 2 cassettes of 200mm wafers

PB12: up to 2 cassettes of 300mm wafers

The Vacuum Cure Advantage

- Faster process: 3.5 hours vs 8+ hours
- Laminar flow reduces/eliminates particles
- More complete cure (5x less outgassing)
- Less film stress and low wafer warpage
- 1.6x to 2x less power and N₂ consumption
- Much lower capital cost, 2-3x lower CoO

COMMON APPLICATIONS

Polyimide and BCB cure

Copper anneal

Aluminum anneal

Contact Us: We offer process demonstrations. If you would like to submit samples, please call us. We can run your samples and provide a detailed process report.

Yield Engineering Systems, Inc.

Call: 1-510-954-6889 (worldwide) or 1-888-YES-3637 (US toll free)

www.yieldengineering.com



PB 8-2P-CP SPECIFICATIONS

For Curing Polyimide, BCB, Low-K Dielectrics & Copper Anneal

SPECIFICATIONS							
HARDWARE							
Clean Room Compatibility		Class 10					
Chamber Cleanliness		Class 1					
Wafer Size		Up to 200mm					
Capacity		Up to 50 8" wafers/batch (two 25 wafer cassettes)					
Operation Temperature		Ambient to 450°C					
N ₂ Flow Rate		1 SCFM					
Nitrogen Consumption		15-25 liters/min.					
Interior Chamber Dimensions		36.62 cm barrel (ID) x 66.52 cm (D) — (14.42" x 26.19")					
Chamber Process Area		23.95 cm (W) x 45.97 cm (D) x 24.69 cm (H) — (9.43" x 18.10" x 9.72")					
Overall System Dimensions		68.96 cm (W) x 145.92 cm (D) x 77.87 cm (H) — (27.15" x 57.45" x 30.64")					
Control Console Dimensions		59.44 cm (W) x 96.01 cm (D) x 23.62 cm (H) — (23.4" x 37.8" x 9.3")					
Chamber Material		316L stainless steel					
Process Gas Inputs		1 standard, up to 3 optional					
Mass Flow Controllers		Optional - up to 3 for gas mixing					
Laminar Flow Filter		100 micron Mott™ plate filter					
Cleanliness		Particle reduction in most applications					
SOFTWARE							
Number of Recipes	Number of Recipes		8 temperature profiles				
Number of Steps for Each Recipe		16 program steps					
Range of Segment Time		0-99 hours					
Resolution of Timer Setting	Resolution of Timer Setting		1 minute				
PERFORMANCE							
Temperature Uniformity		± 5°C during dwell after all temperature points have stabilized for 15 minutes					
Average Heat-Up Rate (150°C - 450°C)		5°C/min. Empty Chamber Load Dependent					
Average Cool-Down Rate (450°C - 150°C)		4°C/min. Empty Chamber Load Dependent					
Oxygen Concentration		10 ppm over background					
ADDITIONAL							
Power Requirements		208V, 40 amps, 50/60 Hz, 3 phase					
Tool Weight (approx.)		575 lbs (261 kgs)					
# OF CASSETTES THAT F	IT INSIDE THE	LAMINAR F	LOW ZONE				
2 inch wafers	9 cassettes		150 mm wafers	3 cassettes			
3 inch wafers	6 cassettes		200 mm wafers	2 cassettes			
100 mm wafers	3 cassettes		300 mm wafers	0 cassettes			
125 mm wafers	3 cassettes						

Tool temperature performance is a combination of temperature control accuracy and temperature uniformity. Accuracy is the deviation of the average product temperature from the set point. Uniformity is the deviation between the maximum and minimum product temperatures and is not related to the set point. Accuracy is calculated as set point – average temperature. Uniformity is calculated as (max-min)/(max+min). YES-PB series tools have dwell accuracy of +/-1.5°C after stabilization. After stabilizing at dwell, all product temperatures should be within 10°C or 14°C of each other (depending on the tool).

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PB 12-2P-CP SPECIFICATIONS

For Curing Polyimide, BCB, Low-K Dielectrics & Copper Anneal

		SPECIFIC	CATIONS			
HARDWARE						
Clean Room Compatibility		Class 10				
Chamber Cleanliness		Class 1				
Wafer Size		Up to 300mm				
Capacity		Up to 50 12" wafers/batch (two 25 wafer cassettes)				
Operation Temperature		Ambient to 450°C				
N ₂ Flow Rate		1 SCFM				
Nitrogen Consumption		15-25 liters/min.				
Interior Chamber Dimensions		54.34 cm barrel (ID) x 104.06 cm (D) — (21" x 40.97")				
Chamber Process Area		37.592 cm (W) x 56.64 cm (D) x 36.07 cm (H) — (14.8" x 22.3" x 14.2")				
Overall System Dimensions		84.48 cm (W) x 174.57 cm (D) x 138.7 cm (H) — (35.23" x 68.73" x 54.61")				
Control Console Dimensions		59.44 cm (W) x 96.01 cm (D) x 23.62 cm (H) — (23.4" x 37.8" x 9.3")				
Chamber Material		316L stainless steel				
Process Gas Inputs		1 standard, up to 3 optional				
Mass Flow Controllers		Optional - up to 3 for gas mixing				
Laminar Flow Filter		100 micron Mott™ plate filter				
Cleanliness		Particle reduction in most applications				
SOFTWARE						
Number of Recipes	Number of Recipes		8 temperature profiles			
Number of Steps for Each Recipe		16 program steps				
Range of Segment Time		0-99 hours				
Resolution of Timer Setting		1 minute				
PERFORMANCE						
Temperature Uniformity		± 7°C during dwell after all temperature points have stabilized for 15 minutes				
Average Heat-Up Rate (150°C	Average Heat-Up Rate (150°C - 450°C)		3.5°C/min. Empty Chamber Load Dependent			
Average Cool-Down Rate (45	Average Cool-Down Rate (450°C - 150°C)		3.0°C/min. Empty Chamber Load Dependent			
Oxygen Concentration		10 ppm over background				
ADDITIONAL						
Power Requirements		208V, 40 amps, 50/60 Hz, 3 phase				
Tool Weight (approx.)		894 lbs (406 kgs)				
# OF CASSETTES THAT F	IT INSIDE THE	LAMINAR F	LOW ZONE			
2 inch wafers	25 cassettes		150 mm wafers	10 cassettes		
3 inch wafers	15 cassettes		200 mm wafers	3 cassettes		
100 mm wafers	10 cassettes		300 mm wafers	2 cassettes		
125 mm wafers	10 cassettes					

Tool temperature performance is a combination of temperature control accuracy and temperature uniformity. Accuracy is the deviation of the average product temperature from the set point. Uniformity is the deviation between the maximum and minimum product temperatures and is not related to the set point. Accuracy is calculated as set point – average temperature. Uniformity is calculated as (max-min)/(max+min). YES-PB series tools have dwell accuracy of +/-1.5°C after stabilization. After stabilizing at dwell, all product temperatures should be within 10°C or 14°C of each other (depending on the tool) and within 7°C or 8.5°C of set point (depending on the tool).

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